JAP20 Rec'd PCT/PTO 02 AUG 2006

8007-1114

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Hiroki SATO et al.

Conf.

Application No. NEW NATIONAL PHASE

Group

Filed August 2, 2006

Examiner

ALKOXIDE COMPOUND, MATERIAL FOR THIN FILM FORMATION, AND PROCESS FOR THIN FILM FORMATION

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

August 2, 2006

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begin on page 3 of this paper.

Remarks begin on page 6 of this paper.

An $\mbox{\bf Appendix}$ is attached following the signature page of this paper.